

003330 P01 USA/ETCH/METAL/PJS
Application No: 10/824,123
Page 2 of 14

IN THE SPECIFICATION:

Please substitute the following paragraph for the corresponding paragraph of page 1, lines 6-9 of the Specification:

This application is a continuation-in-part of U.S. Patent No. 6,942,929, Application Serial No. 10/042,666, entitled "Process Chamber Having Yttrium-Aluminum Coating" to Han et al, assigned to Applied Materials, Inc. and filed on January 8, 2002, which is herein incorporated by reference in its entirety.